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**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE REQUESTED
EXAMINING GROUP 1763**

PATENT
Attorney Docket No. 07553.0017-00000

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
)	
Mitsuru ISHIKAWA et al.)	Group Art Unit: 1763
)	
Application No.: 09/696,232)	Examiner: Olsen, Allan W.
)	
Filed: October 26, 2000)	Confirmation No.: 5127
)	
For: ETCHING METHOD)	

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

AMENDMENT AFTER FINAL

In reply to the Final Office Action mailed May 30, 2007, the period for response to which extends through August 30, 2007, and pursuant to 37 C.F.R. § 1.116, Applicants propose that this application be amended as follows:

Amendments to the Claims are reflected in the listing of claims beginning on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.